

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of)
SATO et al.)
Application Number: To be Assigned)
Filed: Concurrently Herewith)
For: MANUFACTURING METHOD OF SEMICONDUCTOR)
LASER DIODE)
ATTORNEY DOCKET NO. NITT.0191)

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Applicant has amended the claims in order to correct the claims in accordance with standard U.S. practice. Prior to an examination on the merits, please amend the above-identified application as follows: